

JCCS U.S. PRO  
09/502340  
02/10/00

		Subclass	ISSUE CLASSIFICATION
		Class	

**PATENT NUMBER**

**U.S. UTILITY Patent Application**

O.I.P.E.T.

**PATENT DATE**

SCANN

- 9 -

APPLICATION NO. 09/502340	CONT/PRIOR YES	CLASS 117	SUBCLASS 13	ART UNIT 1765	EXAMINER <i>Anderson</i>
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## APPlicants

Robert Fuerhoff  
Steven Kimbel

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Method and apparatus for controlling diameter of a silicon crystal in a locked seed lift growth process

PTO-2040  
12/89

## **ISSUING CLASSIFICATION**

Continued on Issue Slip Inside File Jacket

TERMINAL DISCLAIMER		DRAWINGS			CLAIMS ALLOWED	
		Sheets Drwg.	Figs. Drwg.	Print Fig.	Total Claims	Print Claim or O.G.
<input checked="" type="checkbox"/>	The term of this patent subsequent to _____ (date) has been disclaimed.					
<input checked="" type="checkbox"/>	The term of this patent shall not extend beyond the expiration date of U.S Patent No. _____	(Assistant Examiner)		(Date)		
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<b>NOTICE OF ALLOWANCE MAILED</b>						
<b>ISSUE FEE</b>						
		Amount Due			Date Paid	
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(Legal Instruments Examiner) (Date)						

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